

ABSTRACT

A component-mounted substrate moved to a specified substrate
5 position by a substrate holding-and-moving device is delivered from
the top of the substrate holding-and-moving device to a substrate
discharge holder, and then while the substrate discharge holder is not
moved, the substrate holding-and-moving device is moved to another
substrate position, where a new substrate is received.
10 Consequently, a later-executed movement operation for moving the
new substrate to a substrate mounting region by the substrate
holding-and-moving device and a transfer operation for transferring
the component-mounted substrate to an unloader unit by the
substrate discharge holder may be performed in parallel with each
15 other without being influenced from each other's operation.